

**RESULT LIST**

3 results found in the Worldwide database for:

**bulk and acoustic** in the title AND **rms** or **"root mean square"** in the title or abstract

(Results are sorted by date of upload in database)

**1 Thin film bulk acoustic resonator and method of producing the same**

Inventor: YAMADA TETSUO (JP); NAGAO KEIGO (JP); Applicant:

(+1)

EC: H03H9/17A1A; B06B1/06E; (+5)

IPC: **B06B1/06; G10K11/04; H03H3/02** (+11)

Publication info: **US2005093397** - 2005-05-05

**2 Thin-film bulk acoustic oscillator and method of manufacturing same**

Inventor: KOMURO EIJU (JP); SAITOU HISATOSHI (JP); Applicant: TDK CORP (JP)

(+1)

EC:

IPC: **H01L41/04; H01L41/08; H01L41/09** (+13)

Publication info: **US2005006984** - 2005-01-13

**3 Thin film bulk acoustic resonator and method of producing the same**

Inventor: YAMADA TETSUO (JP); NAGAO KEIGO (JP); Applicant:

(+1)

EC: H03H9/17A1A; B06B1/06E; (+5)

IPC: **B06B1/06; G10K11/04; H03H3/02** (+11)

Publication info: **US2002190814** - 2002-12-19

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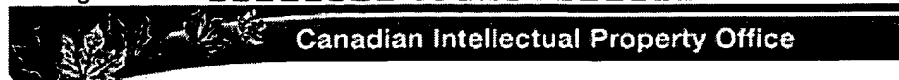
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## Canadian Patents Database

### Search Results 01/24/2006 - 16:29:28

**Search**

Query :

((piezoelectric <near> surface <near>

Query: ((piezoelectric <near> surface <near> (rms <or> "root mean square"))))

3 documents out of 1660521 matched your query. Click on its number to view the details of the document.

**Note:** All document detail pages now appear on a new Browser Window.

1. [2114988](#) ULTRASONIC ANGIOPLASTY BALLOON CATHETER 43%
2. [1043270](#) METHOD AND APPARATUS FOR ELECTROMECHANICAL RECORDING OF SHORT WAVELENGTH MODULATION IN A METAL MASTER 15%
3. [2393579](#) METHOD FOR COMPENSATING FOR REMOTE CLOCK OFFSET 03%

Last Modified: 2002-12-31



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Searching PCT (Full Text)...

[Search Summary]

Results of searching in PCT (Full Text) for:

piezoelectric and ( rms or "root mean square" ) near ( surface or roughness ): 1 record

Showing record 1 to 1 of 1 :

Refine Search

piezoelectric and (rms or "root mean square") near (s

Title

1. **(WO 03/065575) SURFACE ACOUSTIC WAVE DEVICES BASED ON UNPOLISHED NANOCRYSTALLINE DIAMOND**

Search Summary

**piezoelectric NEAR surface:** 2327 occurrences in 734 records.

**rms NEAR surface:** 682 occurrences in 315 records.

**"root mean square" NEAR surface:** 0 occurrences in 0 records.

(rms NEAR surface OR "root mean square" NEAR surface): 315 records.

(piezoelectric NEAR surface AND (rms NEAR surface OR "root mean square" NEAR surface)): 1 record.

**piezoelectric NEAR roughness:** 1 occurrence in 1 record.

**rms NEAR roughness:** 1167 occurrences in 417 records.

**"root mean square" NEAR roughness:** 0 occurrences in 0 records.

(rms NEAR roughness OR "root mean square" NEAR roughness): 417 records.

(piezoelectric NEAR roughness AND (rms NEAR roughness OR "root mean square" NEAR roughness)): 0 records.

((piezoelectric NEAR surface AND (rms NEAR surface OR "root mean square" NEAR surface)) OR (piezoelectric NEAR roughness AND (rms NEAR roughness OR "root mean square" NEAR roughness))): 1 record.

Search Time: 6.87 seconds.



	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	28	piezoelectric same ("root mean square" or rms) same roughness	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT; IBM_T DB	2006/01/2 4 16:21	
2	IS&R	L2	699	(310/320,324).CCLS.	USPAT	2006/01/2 4 16:21	
3	IS&R	L3	190	(310/320,324).CCLS.	US- PGPUB ; EPO; JPO; DERWE NT; IBM_T DB	2006/01/2 4 16:21	